

FIG. 1

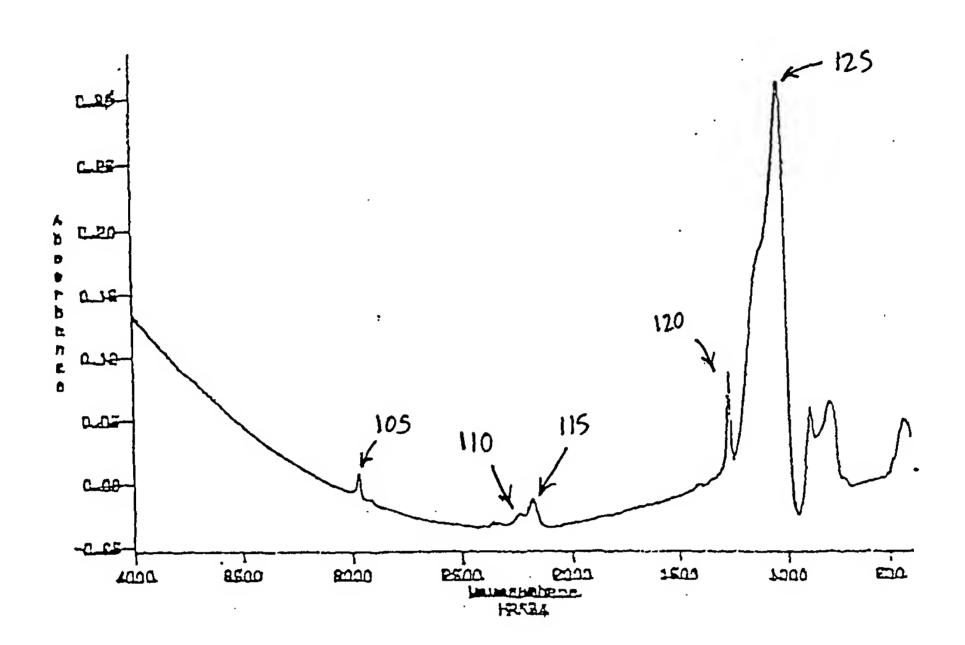


FIG. 2

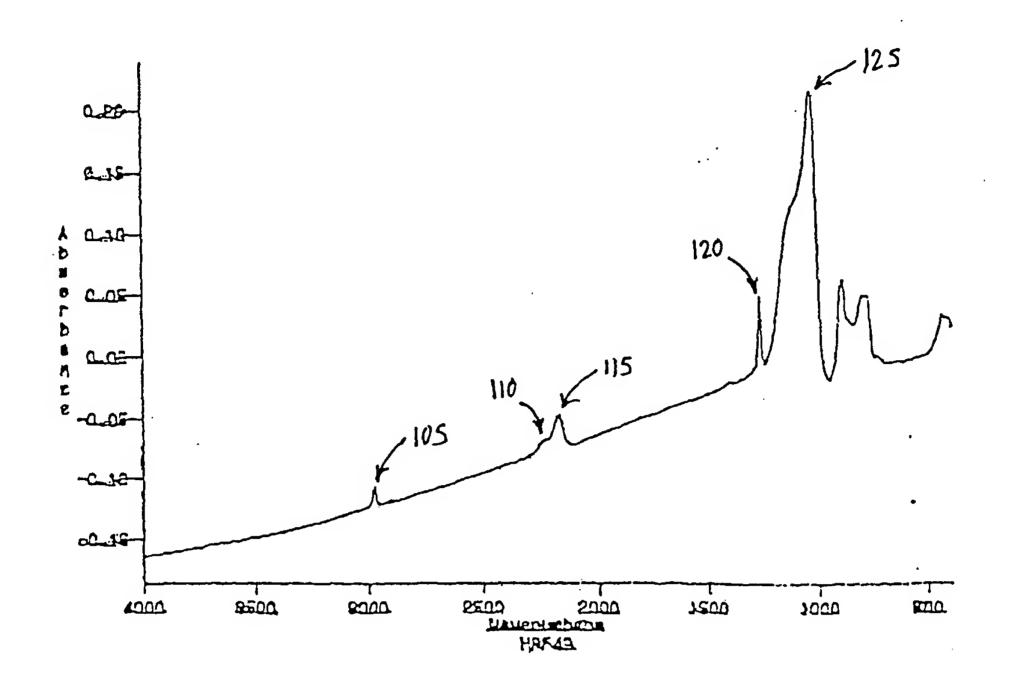


FIG. 3

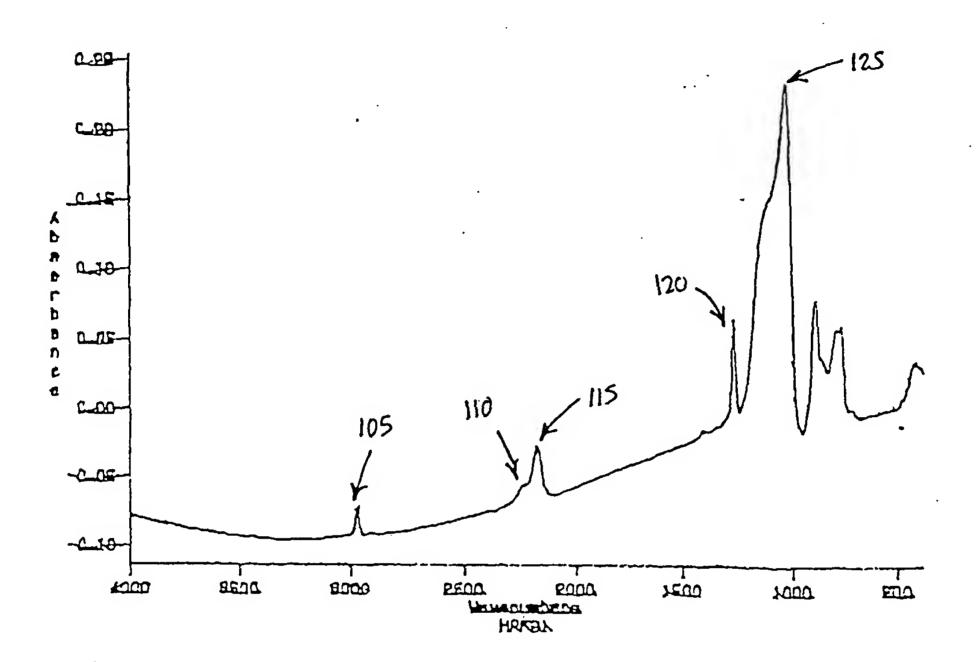


FIG. 4

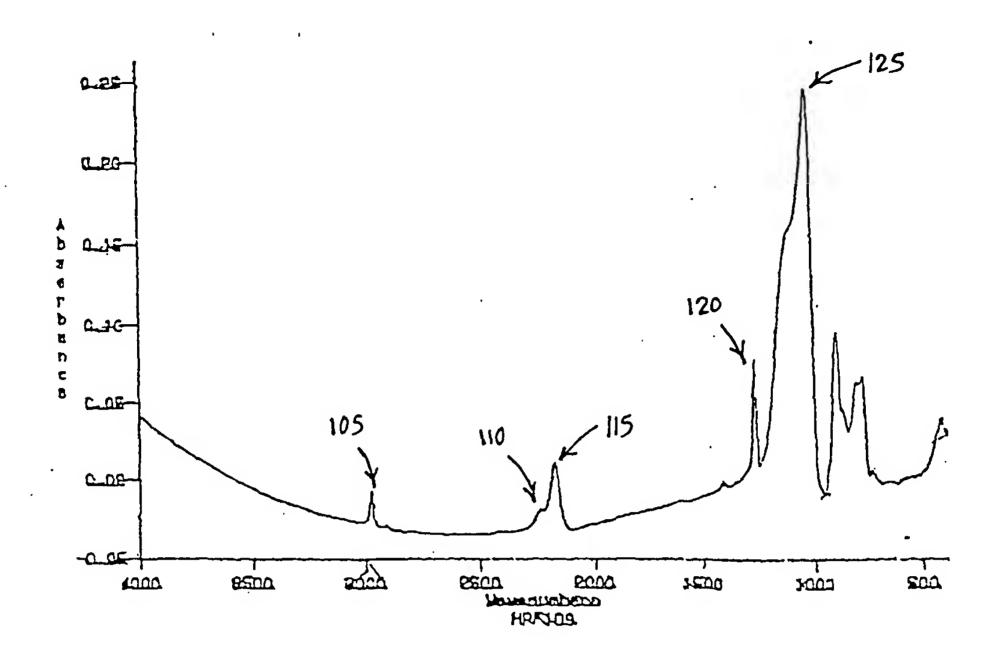


FIG. 5

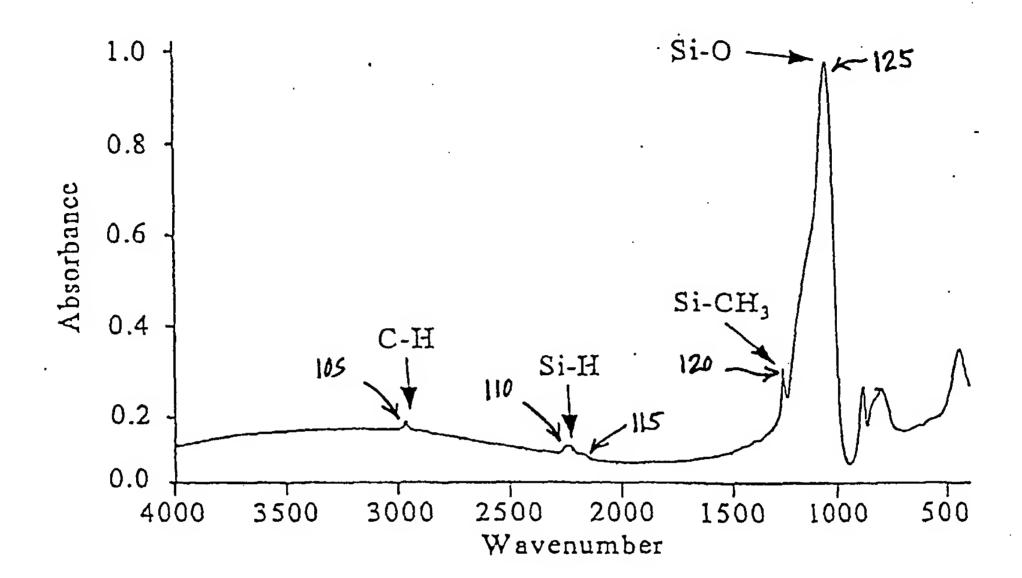
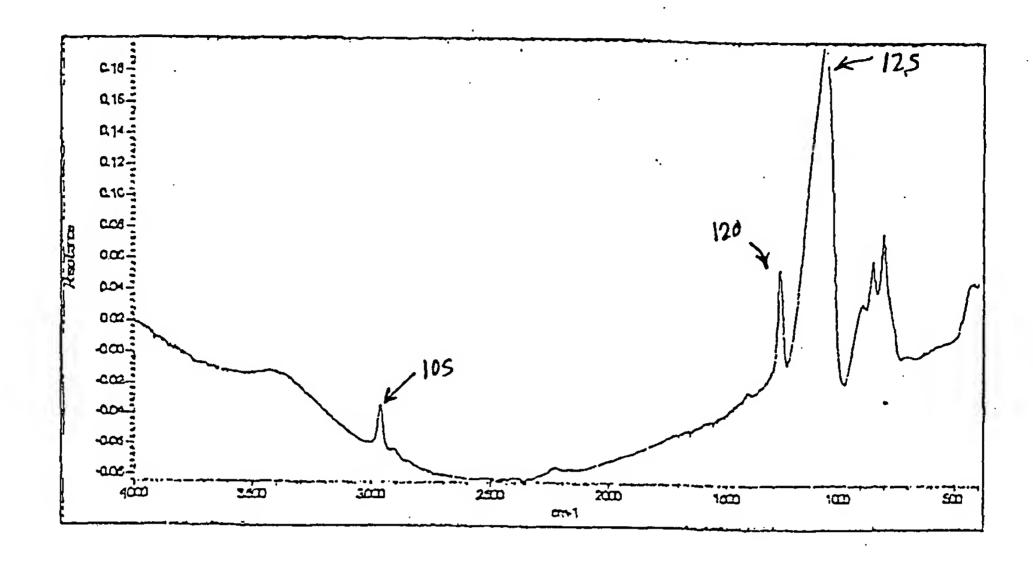


FIG. 6



**FIG.** 7

FIG. 8

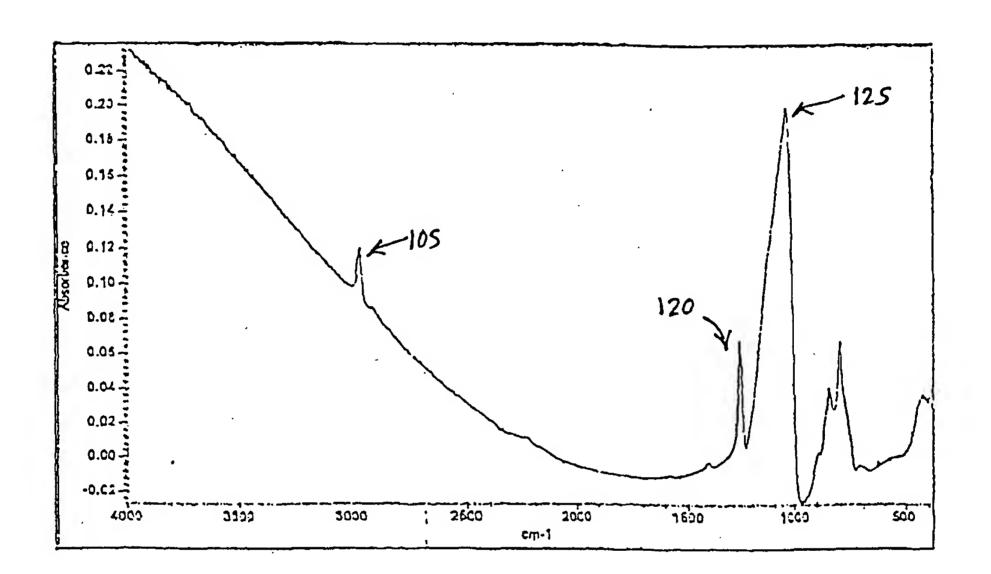
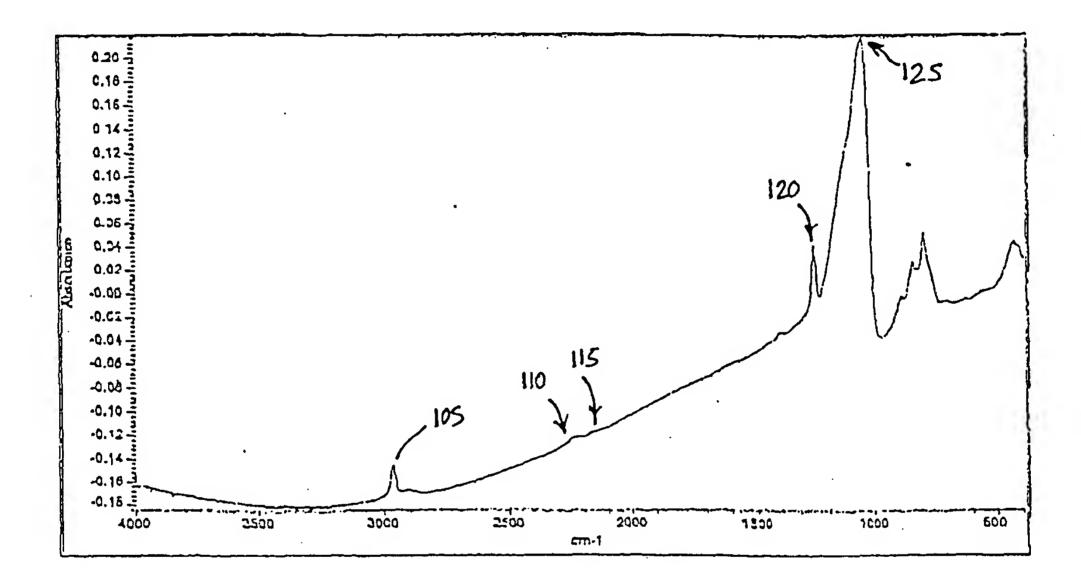


FIG. 9



**FIG. 10** 

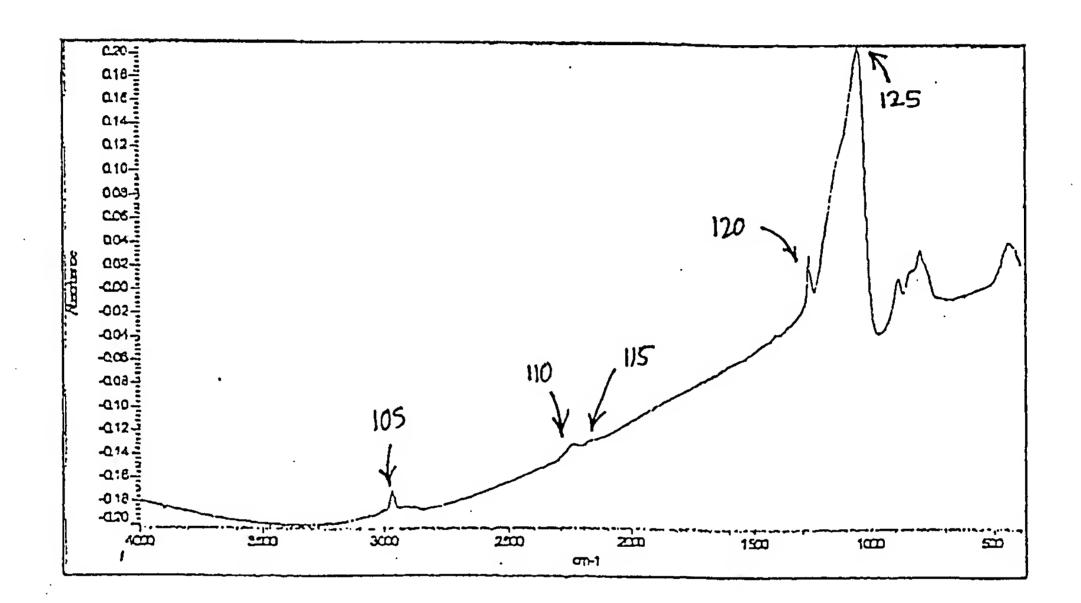
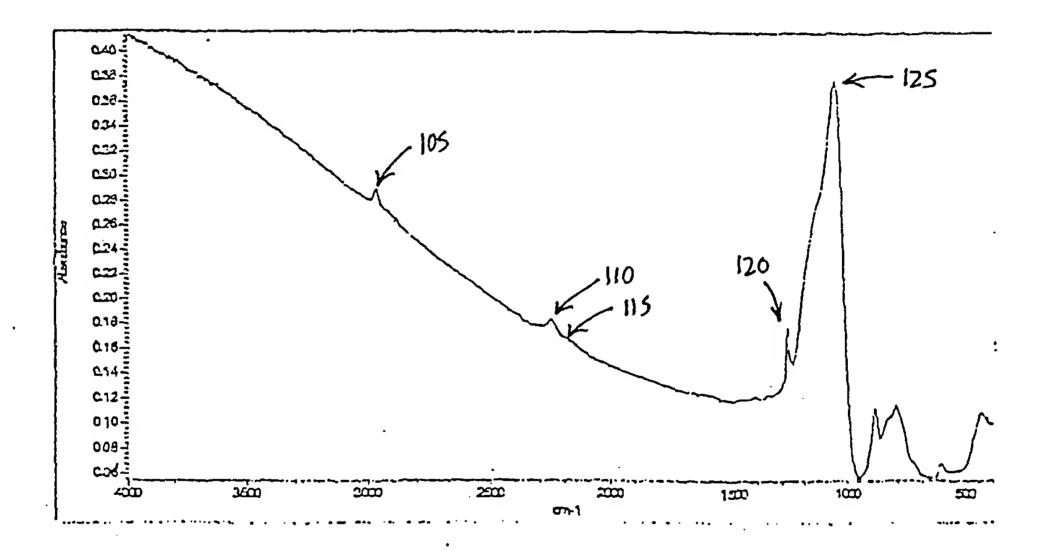
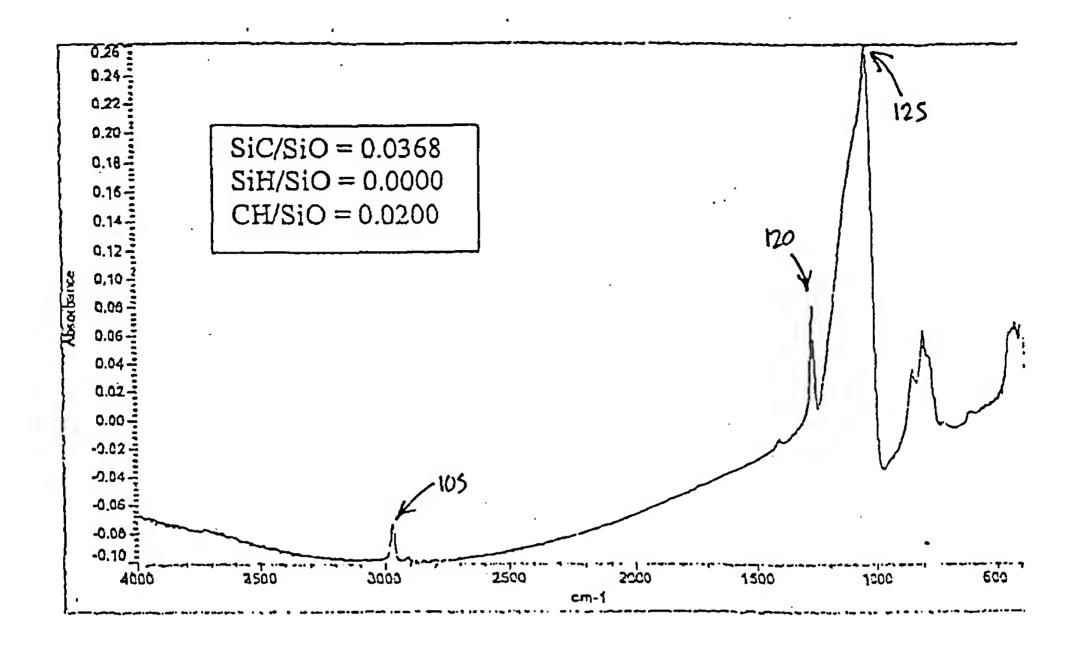


FIG. 11





**FIG. 12** 

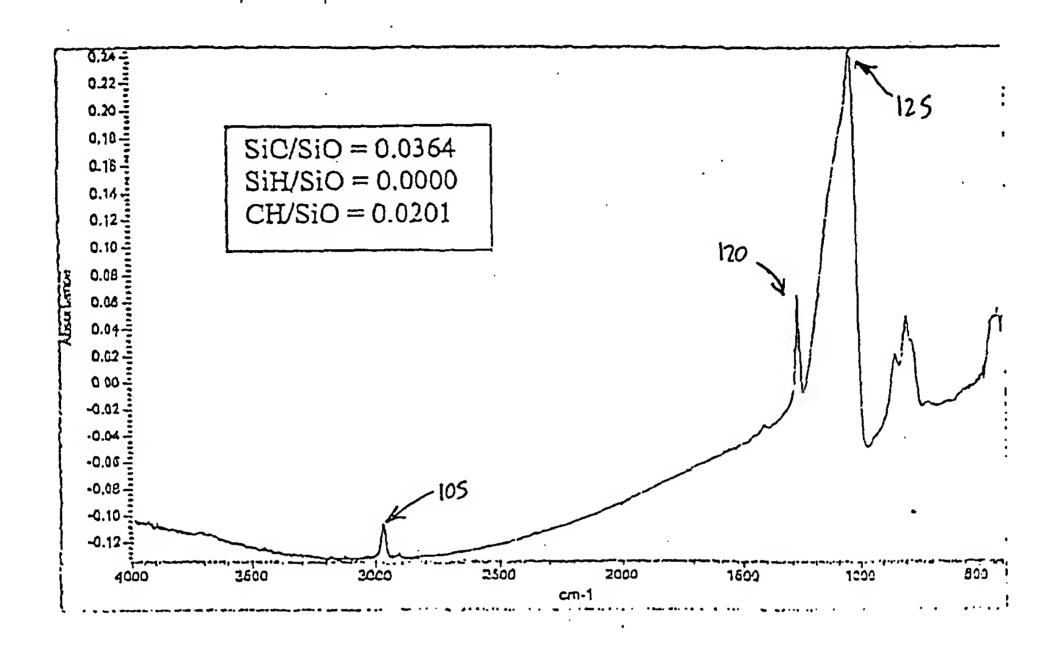


FIG. 13

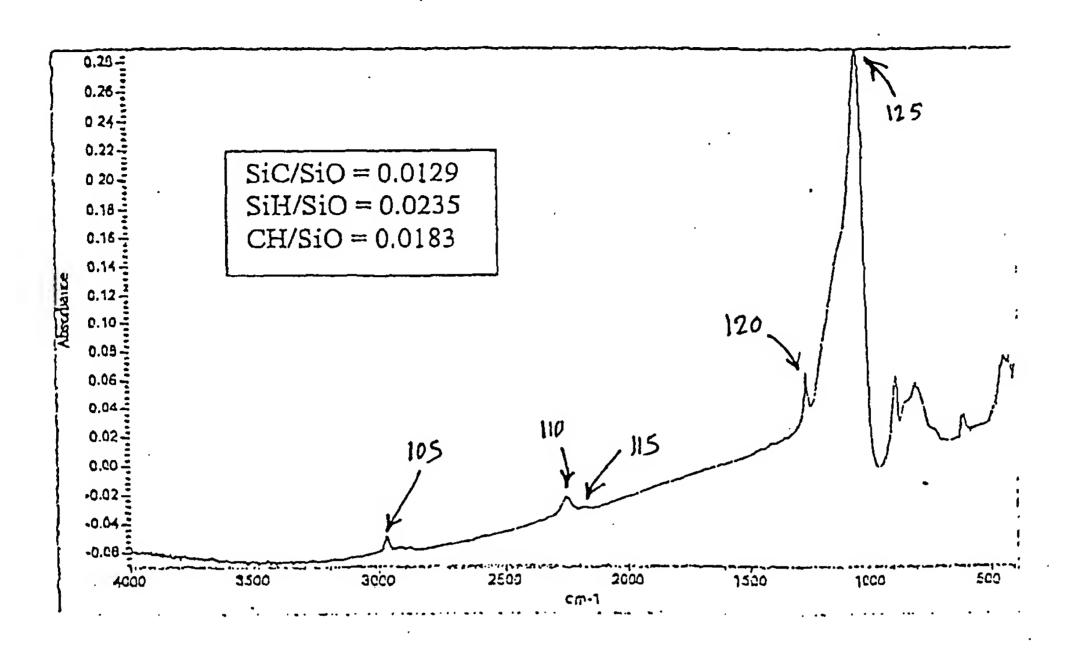


FIG. 14

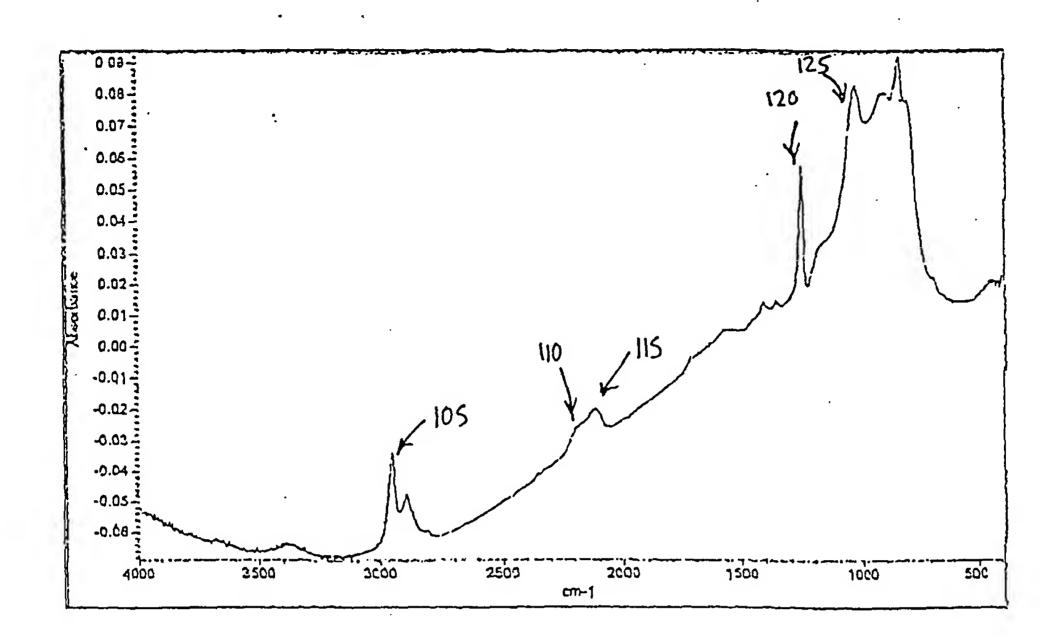
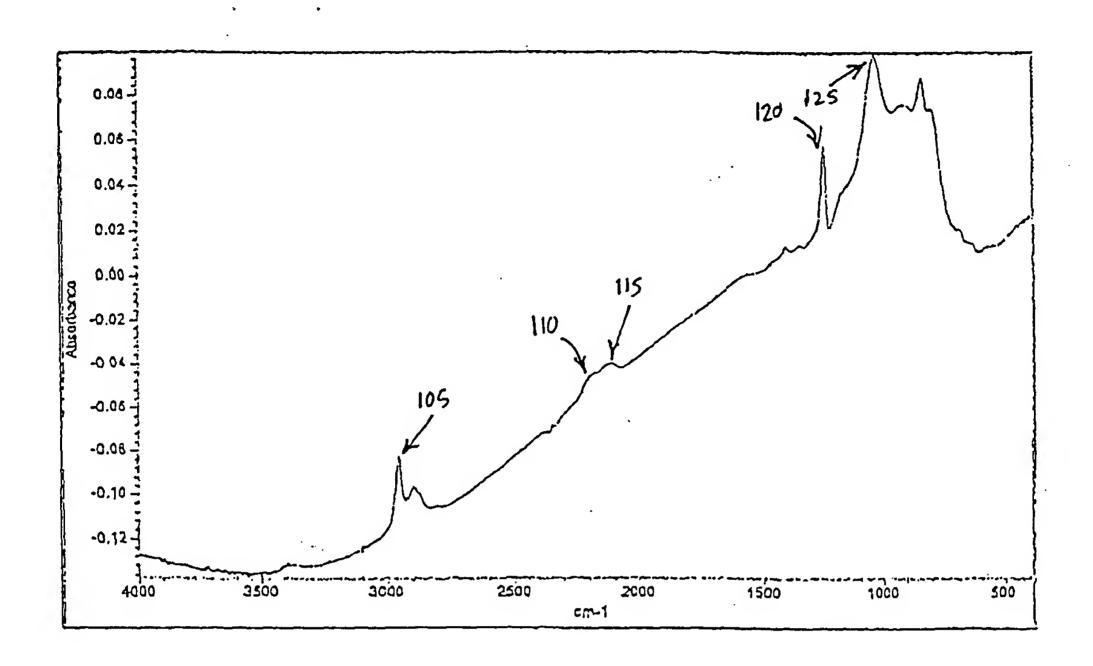


FIG. 15



**FIG. 16** 

## DIELECTRIC LAYER FOR A SEMICONDUCTOR DEVICE AND METHOD OF PRODUCING THE SAME Inventor: John MACNEIL Serial No. [NEW] - Attorney Docket No. WLJ.068D

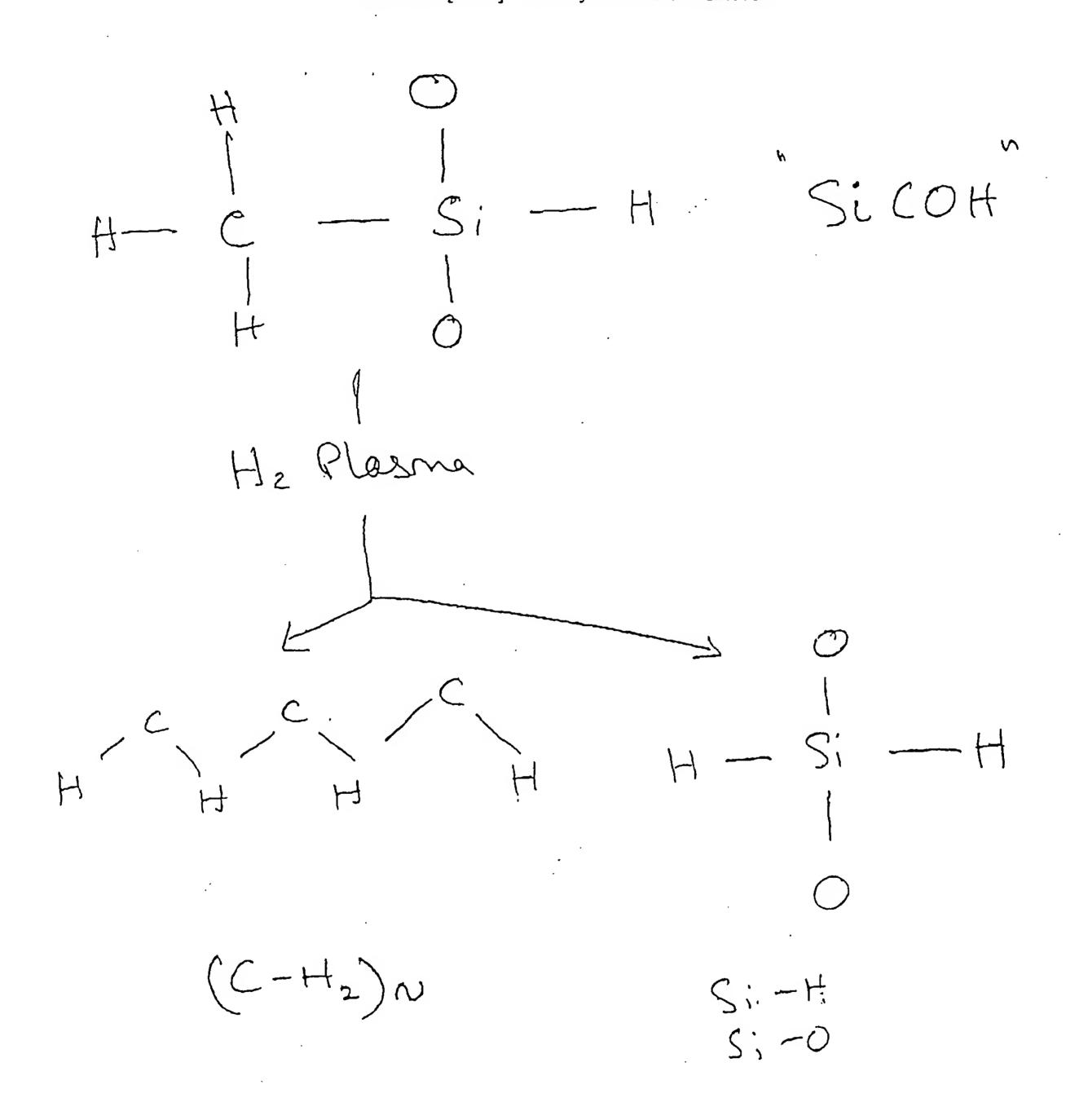


FIG. 17